

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Keisuke KAWAMURA, et al.

SERIAL NO: New U.S. PCT Application Based on PCT/JP03/12563

GAU:

FILED: Herewith

EXAMINER:

FOR: PLASMA PROCESSING SYSTEM AND ITS SUBSTRATE PROCESSING PROCESS, PLASMA ENHANCED CHEMICAL VAPOR DEPOSITION SYSTEM AND ITS FILM DEPOSITION PROCESS

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

REFERENCES

- The applicant(s) wish to make of record the references cited in the International Search Report and listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- Attached is a list of applicant's pending application(s), published application(s) or issued patent(s) which may be related to the present application. In accordance with the waiver of 37 CFR 1.98 dated September 21, 2004, copies of the cited pending applications are not provided. Cited published and/or issued patents, if any, are listed on the attached PTO form 1449.
- A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

- Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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10/519475

2 Rec'd PCT/PTO 28 DEC 2004

SHEET 1 OF 1

Form PTO 1449 (Modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT			ATTY DOCKET NO. 263788US2PCT		SERIAL NO. New U.S. PCT Application Based on PCT/JP03/12563		
			APPLICANT Keisuke KAWAMURA, et al.				
			FILING DATE Herewith		GROUP		
			U.S. PATENT DOCUMENTS				
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
		AO 0 955 665	11/10/99	EP	YES	NO	
		AP 2000-58465	02/25/00	JP(Equivalent to EP 0 961 307)			NO
		AQ 2816365	10/27/98	JP			NO
		AR 2001-274099	10/05/01	JP(Equivalent to US 2001/021422)			NO
		AS 2001-7028	01/12/01	JP(Equivalent to US 6,417,079)			NO
		AT 2001-321662	11/20/01	JP			NO
		AU					
		AV					
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW						
	AX						
	AY						
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner					Date Considered		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							